

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 292873US41PCT		SERIAL NO. 10/584,052	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Stephane POCAS, et al.			
				FILING DATE June 22, 2006		GROUP 2892	
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
/E.J./	AA	6,340,812	01/22/02	Yoshihiro IZUMI, et al			
↓	AB	2004/0097008 A1	05/2004	Glen J. LEEDY			
	AC	5,374,564	12/20/94	Michael BRUEL			
	AD	6,281,039	08/28/01	MARION			
	AE	2004/0014299	01/22/04	Hubert MORICEAU, et al.			
	AF	5,880,010	03/1999	Davison, HOWARD L.			
	AG	6,097,096	08/2000	GARDNER, et al.			
	AH	6,465,892	10/2002	SUGA, Tadatomo			
	AI	6,809,008	10/2004	HOLM, et al.			
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	AK	6,902,987	06/2005	TONG, et al.			
	AL	7,452,745	11/2008	DUPONT, et al.			
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	AN	2002/0173118	11/2002	DIETRICH, et al.			
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		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
/E.J./	AO	2 783 969	03/31/00	France (equivalent of US 6, 281, 039)		X	
↓	AP	2 816 445	05/10/02	France (equivalent of US 2004/0014299)		X	
	AQ	WO/2003/028101	04/2003	France (equivalent of US 2005/0020029)		X	
	AR	WO/01/18853 A1	03/2001	World Intellect (equivalent of US 7,208,392)		X	
	AS						
	AT						
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	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/E.J./	AW	Q.-Y. TONG, et al., "SEMICONDUCTOR WAFER BONDING: SCIENCE AND TECHNOLOGY", JOHN WILEY & SONS, INC., XP 008042464, pages 215-219, 1999.					
↓	AX	Goran THUNGSTROM, et al., "CONTACTS TO MONOCRYSTALLINE N - AND P- TYPE CILLICON BY WAFER BONDING USING COBALT DISILICIDE", Physica Scripta, Vol. T54, 1994, pages 77-80.					
	AY	ISMAIL, M.S., et al., "PLATINUM SILICIDE FUSION BONDING", Electronics Letters, Vo. 27, No. 13, pages 1153-1155, 1991.					
↓	AZ	PLOESSL, A., et al., "WAFER DIRECT BONDING: TAILORING ADHESION BETWEEN BRITTLE MATERIALS", Materials Science and Engineering, Vol. 25, No. 1-2, pages 1-88, 1999.				<input checked="" type="checkbox"/> Additional References sheet(s) attached	
Examiner /Eric Jones/					Date Considered 01/21/2011		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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/E.J./	BA	2003/0129780	07/2003	Andre AUBERTON-HERVE			
↓	BB	2005/0020029	01/2005	JEAN-SEBASTIEN, Danel			
	BC	2005/0104089	05/2005	ENGELMANN, et al.			
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	BG	2008/0296712	12/04/08	Guy FEUILLET, et al.			
	BH						
	BI						
	BJ						
	BK						
BL							
BM							
BN							
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	DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO			
	BO						
	BP						
	BQ						
	BR						
	BS						
	BT						
	BU						
	BV						
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/E.J./	BW	SHIGETOU, A., et al., "ROOM TEMPERATURE BONDING OF ULTRA-FINE PITCH AND LOW-PROFILED CU ELECTRODES FOR BUMP-LESS INTERCONNECT", Electronic Components and Technology Conference, Vol. 53, pages 848-852, 2003.					
/E.J./	BX	LJUNGBERG, K., et al., "BURIED COBALT SILICIDE LAYERS IN SILICON CREATED BY WAFER BONDING", Journal of the Electrochemical Society, Vol. 141, No. 10, pages 2829-2833, 1994.					
/E.J./	BY	B. ASPAR, et al., "SMART-CUT PROCESS USING METALLIC BONDING: APPLICATION TO TRANSFER OF Si, GaAs, InP THIN FILMS", Electronics Letters, Vol. 35, No. 12, June 10, 1999, pages 1024-1025.					
	BZ					<input type="checkbox"/> Additional References sheet(s) attached	
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